

SDHCAL

Technological prototype

Where we are?

Imad Laktineh

CIEMAT, Gent, IPNL, LAL, LAPP, LLN, LLR, LPC, Protvino, Tsinghua, Tunis

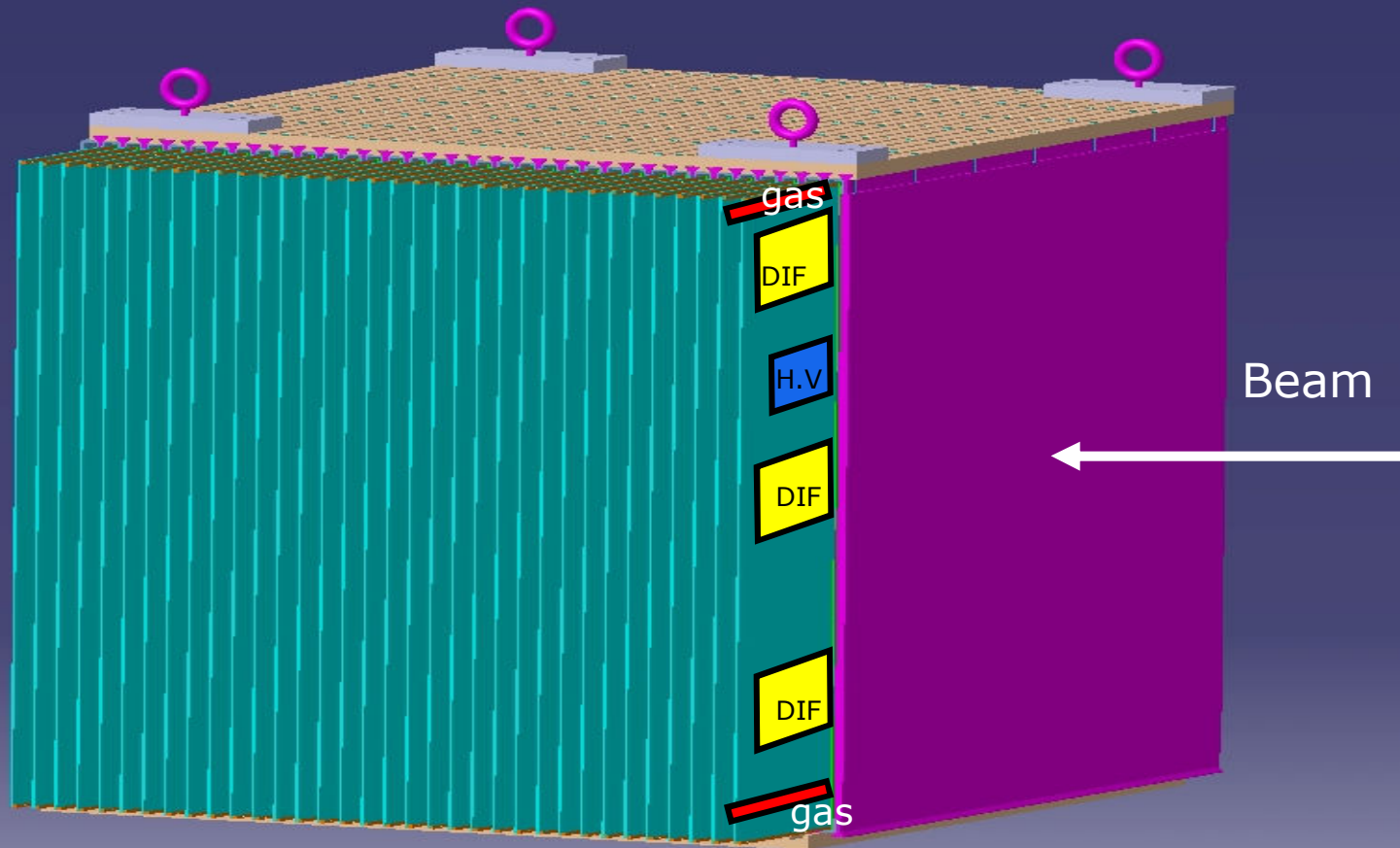
In memoriam



Vladimir Ammosov
10. Feb. 1945 - 11.
Jan. 2010

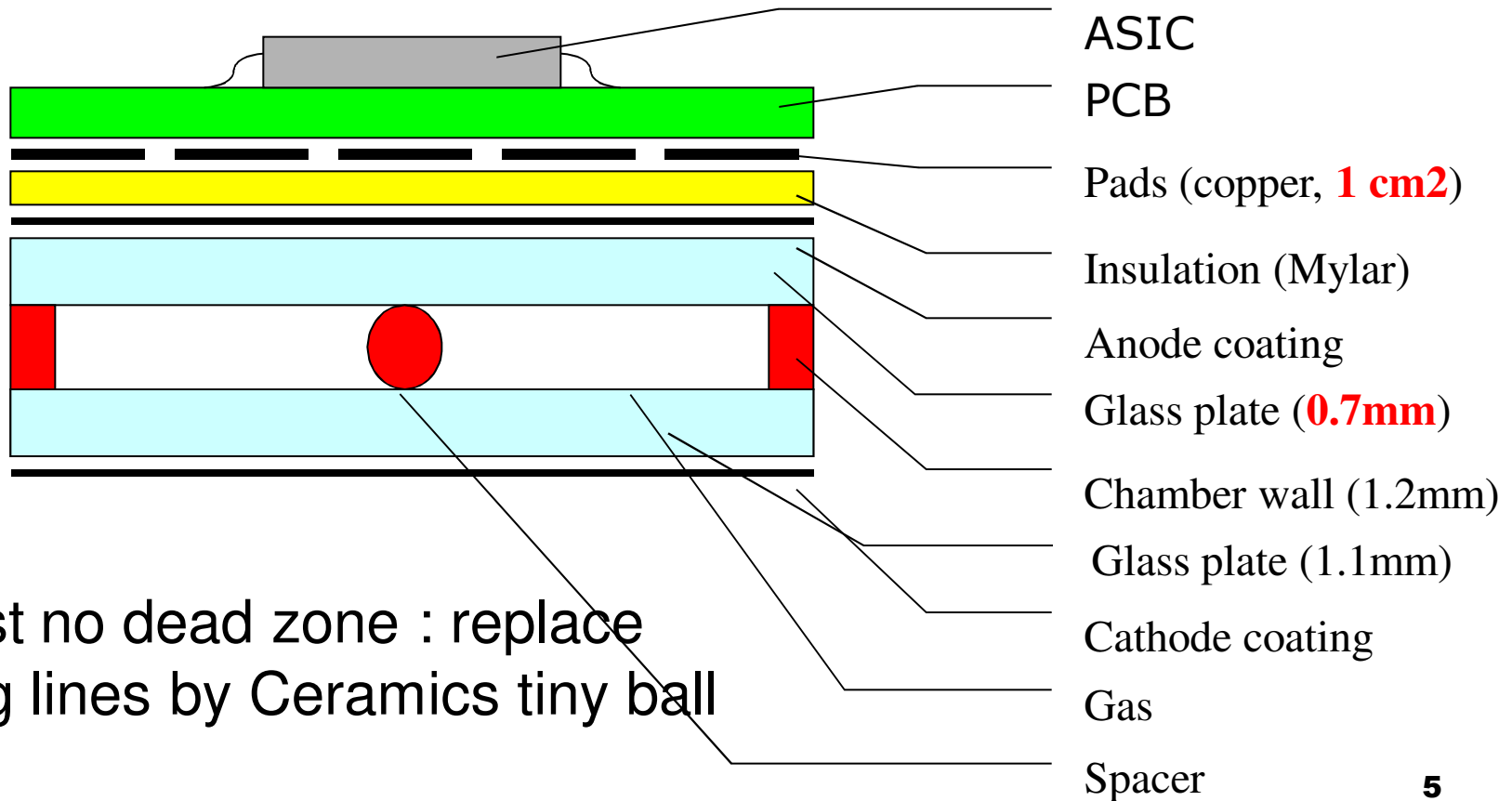
Ingredients of a technological prototype

- Detector
- Electronics
- Mechanical structure
- Services
- Simulation
- Conclusion



Detector

Thickness : 3.225 mm



Almost no dead zone : replace fishing lines by Ceramics tiny ball

Detector

Homogeneity :

within the same detector but also from one detector to another

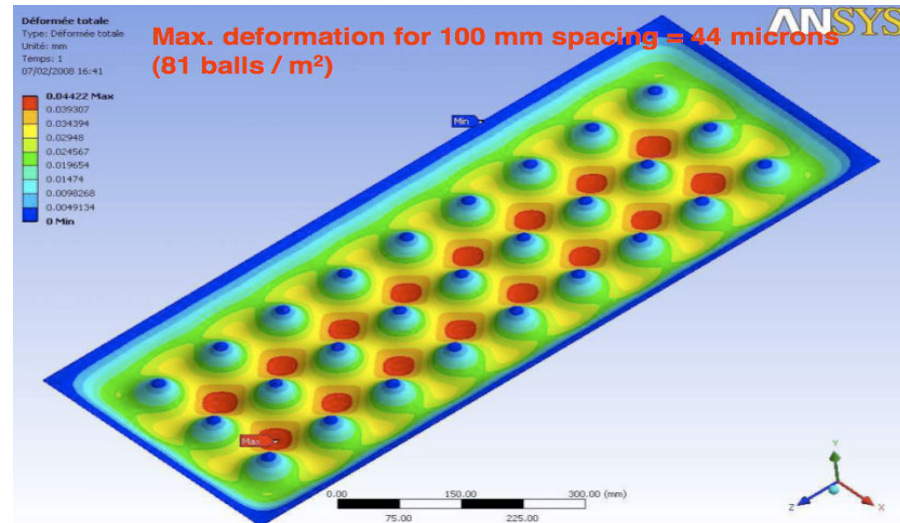
→ Glass : ok

→ Mylar : ok

→ Painting : This is an issue but using the silk screen painting technique this is ok

→ Distance between the two plates : This is very Important ($E = \Delta V / d$)

almost ok



Resistive coating

The problem is to have homogenous painting for large surface:

Graphite: (400 K Ω/\square) Standard but rather high multiplicity
(1.6 pads/mip at 7.4 kV), no HV connection problem

Licron : (> 20 M Ω/\square) : Spray, good multiplicity, HV long-term connection problems (HV lost after few months)

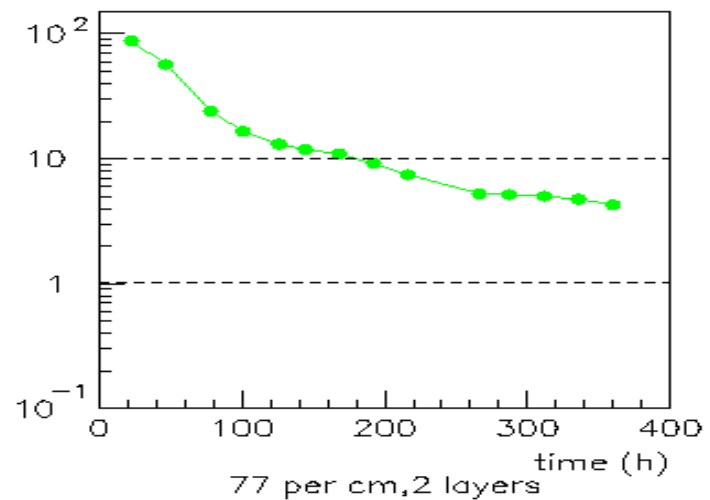
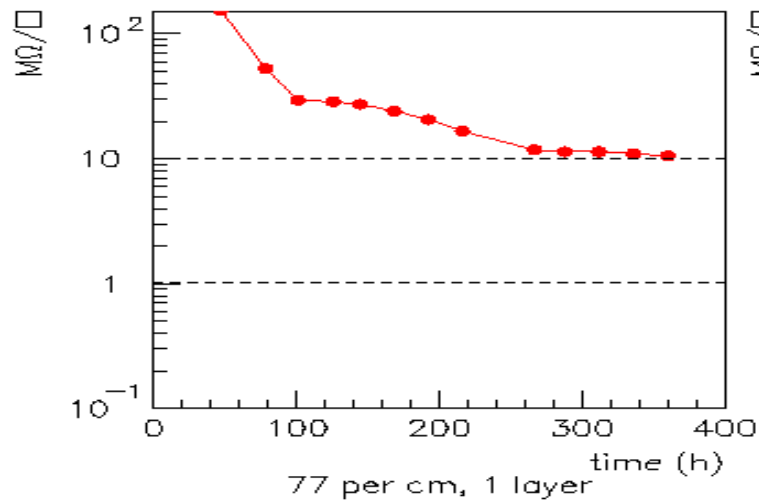
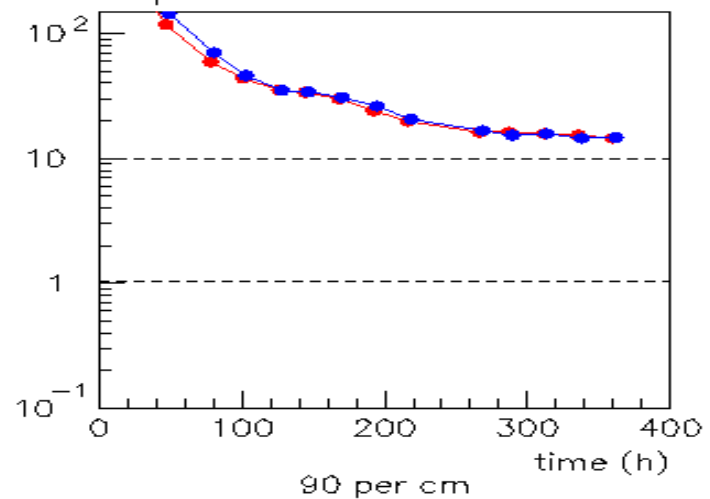
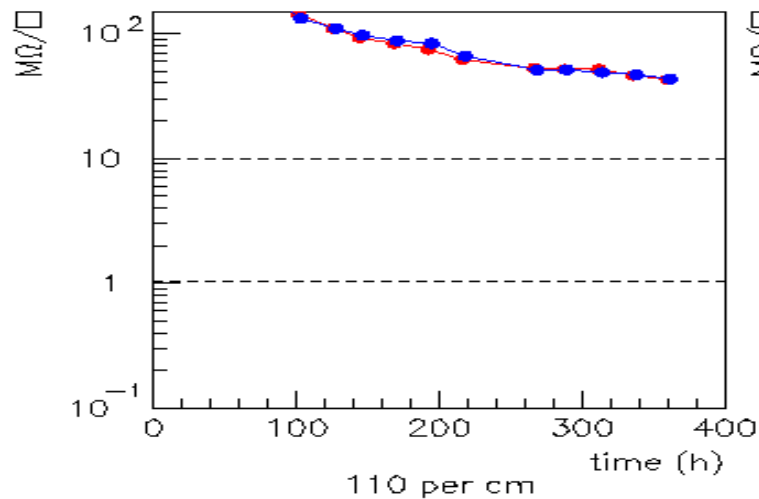
Statguard : (few M Ω/\square) : Liquid painting, stable, no HV connection problem observed so far but homogeneity is not good when painted with a roll → Silk Screen Printing

Silk Screen Printing :

The technique is well known, it provides homogenous and well controlled coating. Used in OPERA GRPCs. Simple tools are needed (reduced cost)



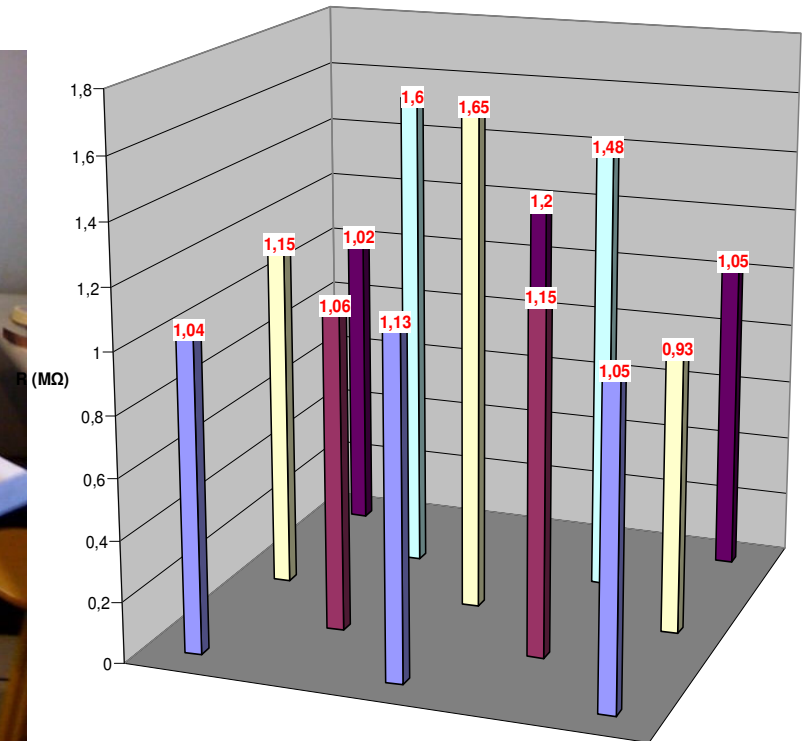
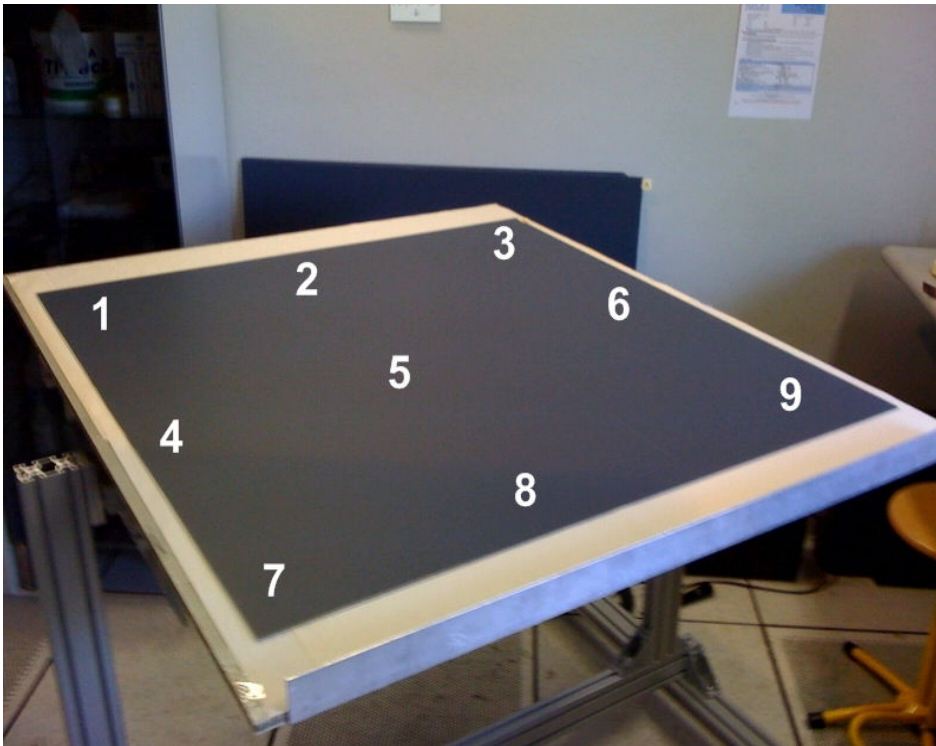
Resistivity control using SSP technique



Silk Screen Printing :

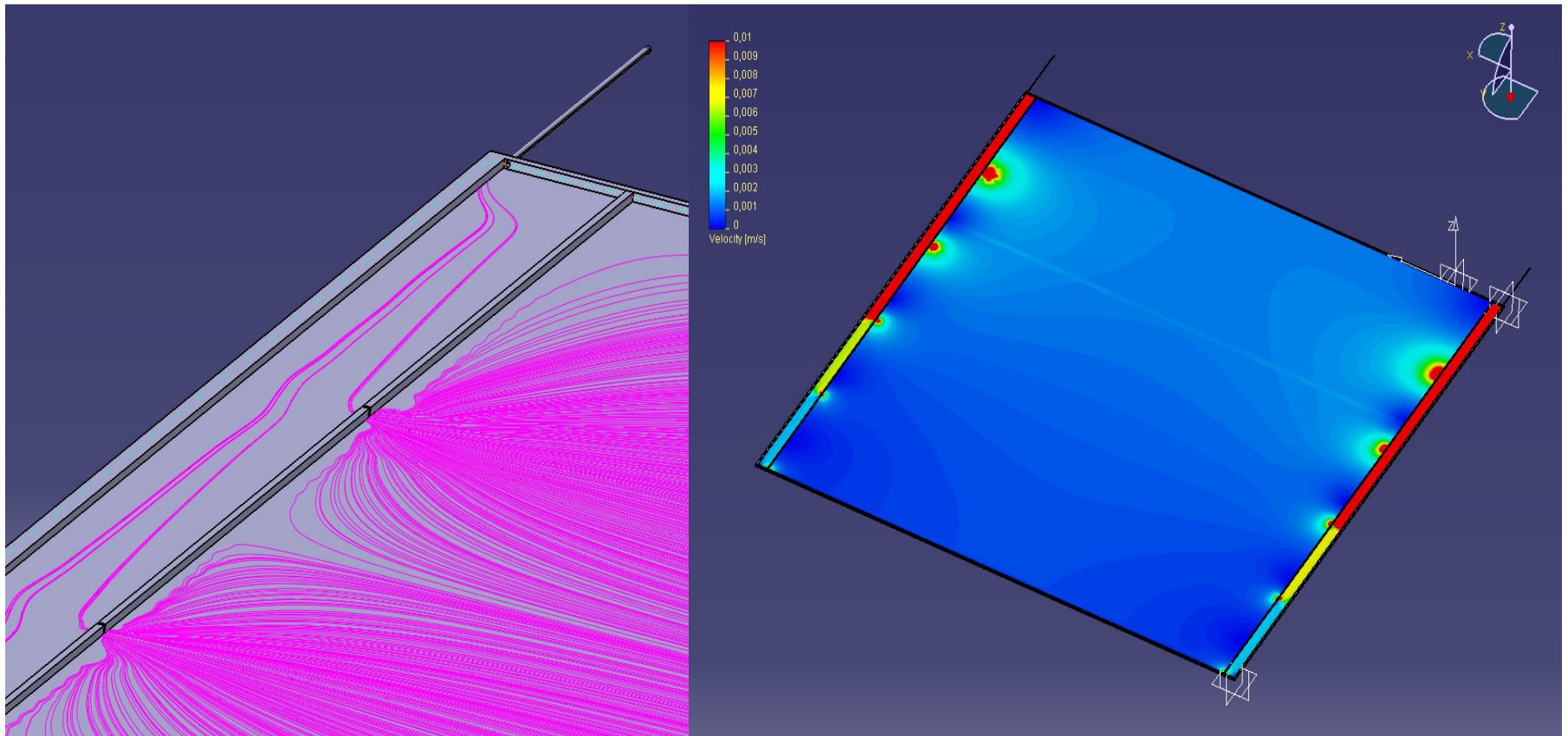
Statguard is not really adapted to Silk Screen Printing. It dries quickly

Colloidal graphite ($\sim 1 \text{ M } \Omega / \square$) is well suited for Silk Screen Printing but drying at high temperature (180°) is needed



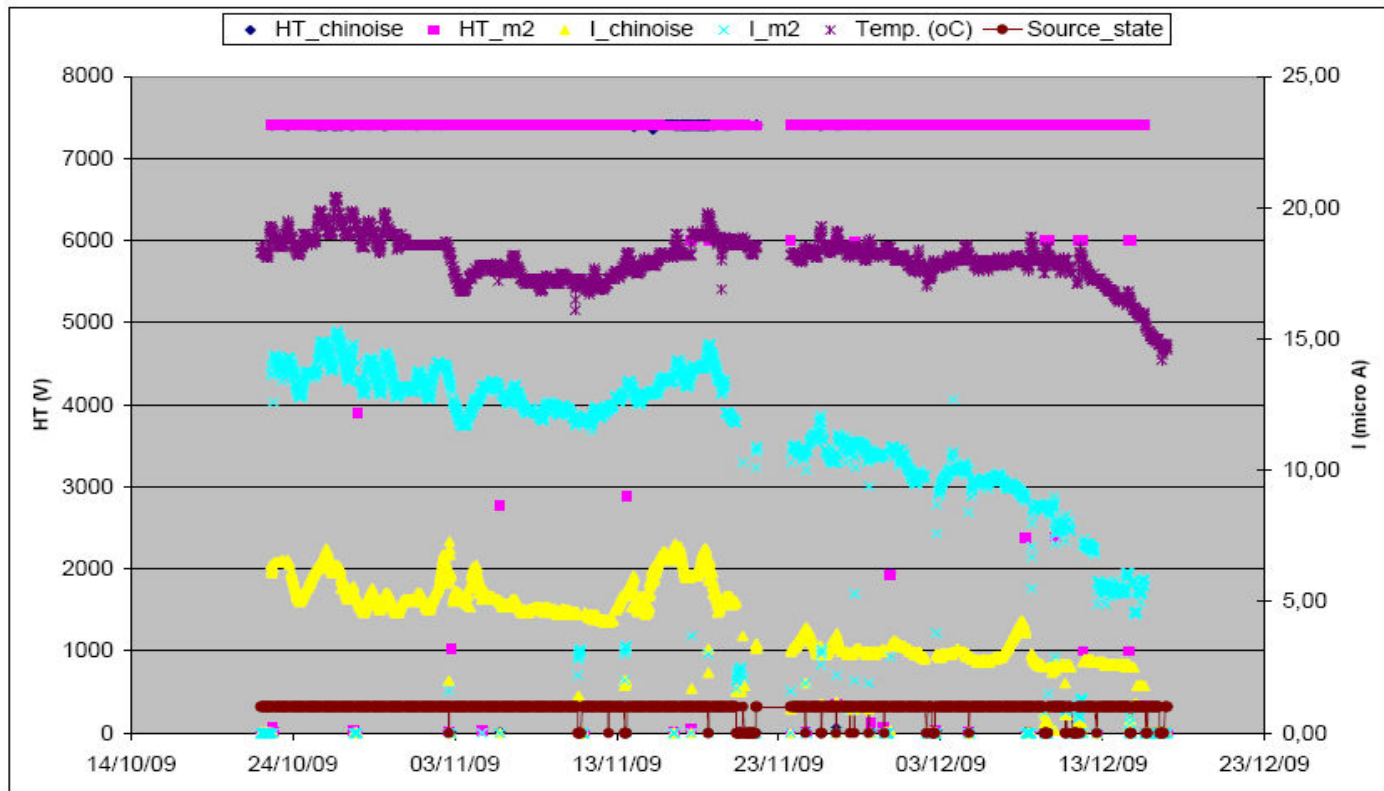
Ratio MAX/MIN = 1.77

Gas circulation system was conceived and checked with sophisticated simulation tools with the aim to reduce gas consumption and to guarantee a well distributed gas
→ Homogeneity



Ongoing aging study

We have 2 GRPCs (standard 1m², semi-conductive small GRPC) in the GIF facility since October 2010). Correlation between gain, temperature, pressure and humidity is currently under study so the pure irradiation effect can be deduced.



Electronics

All Test Beams were done using HR1(2 thr.)

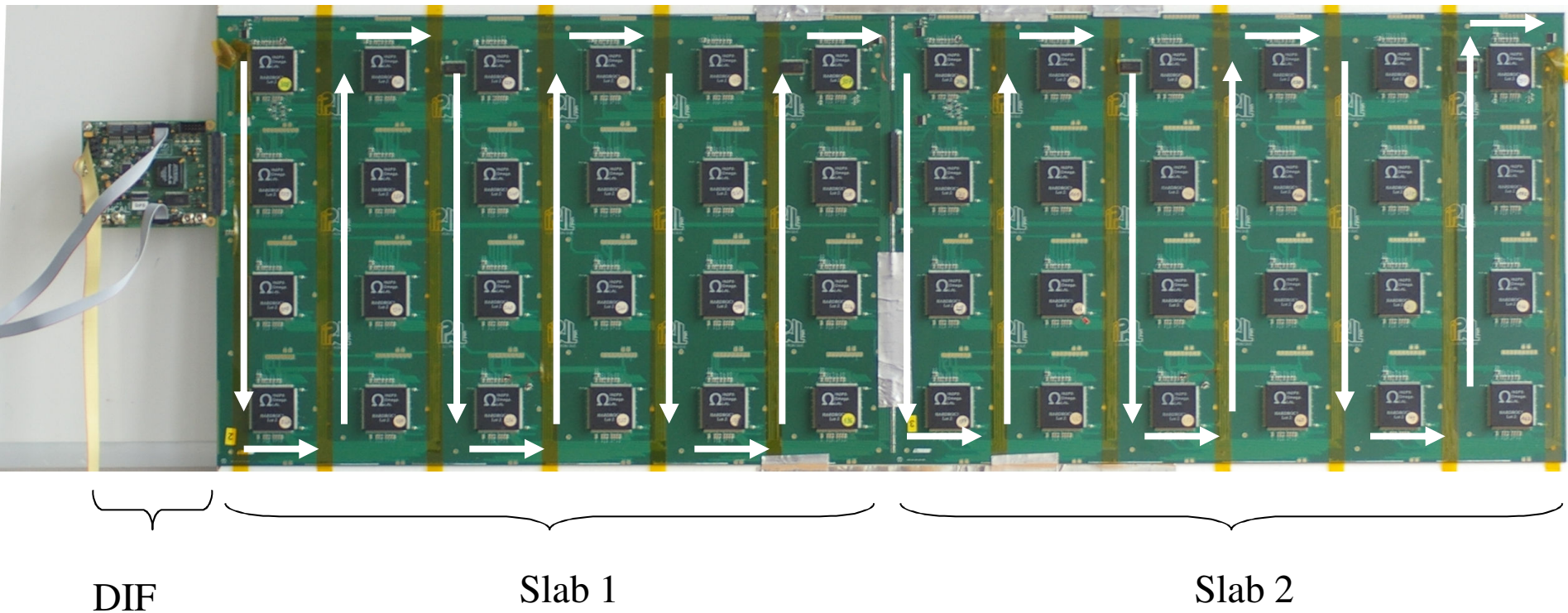
Few bugs with HR1 : ineffective mask, partial P.P

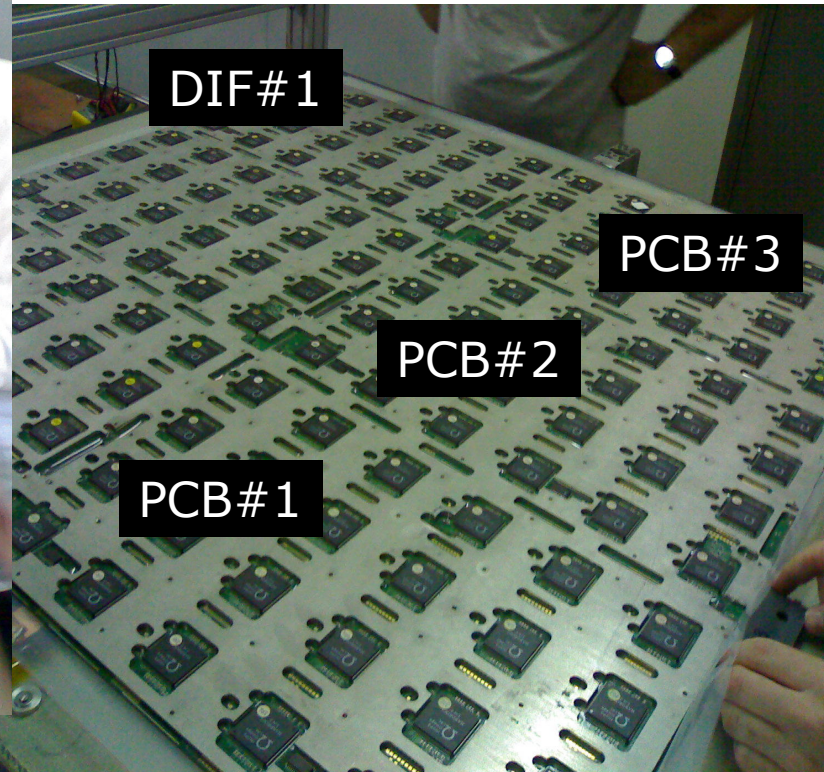
HR1 → HR2(3 thr.): but problems with some
configurations loading

HR2→HR2b : bugs free

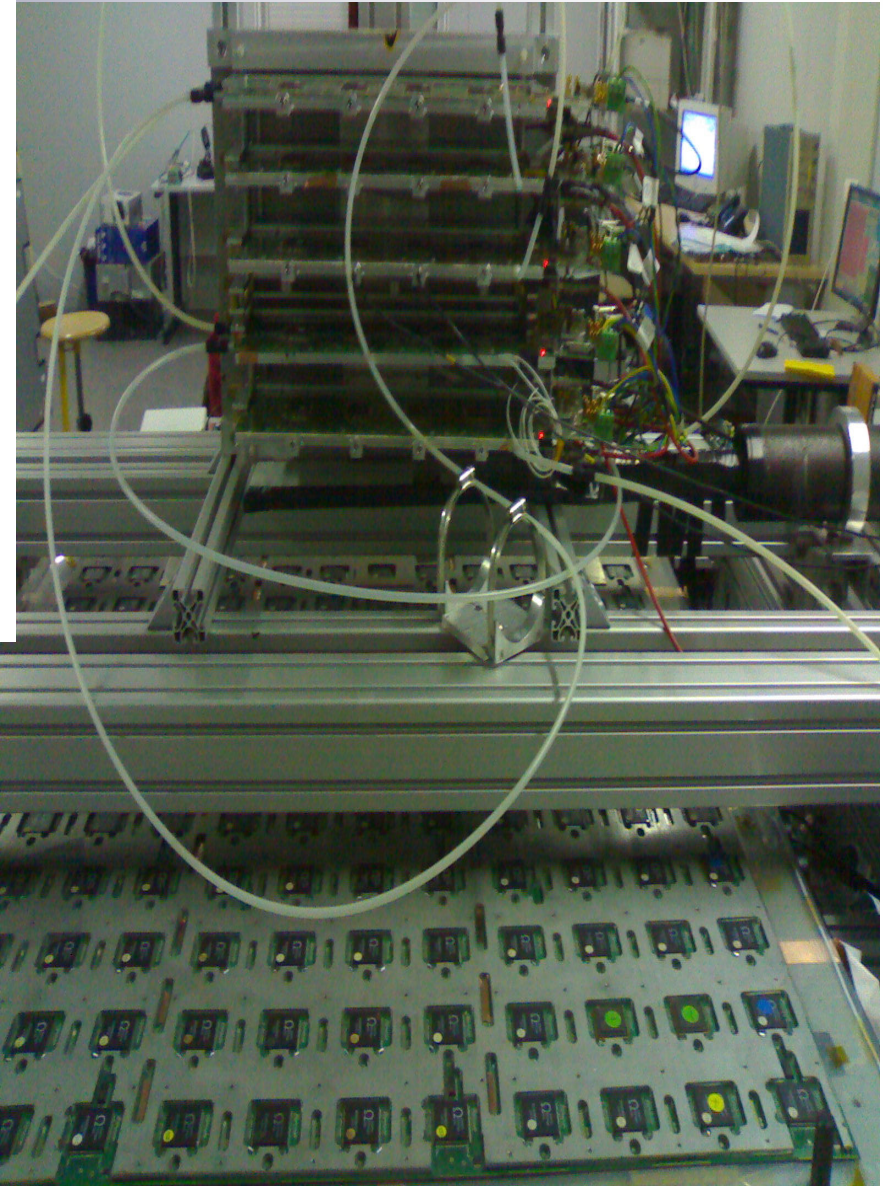
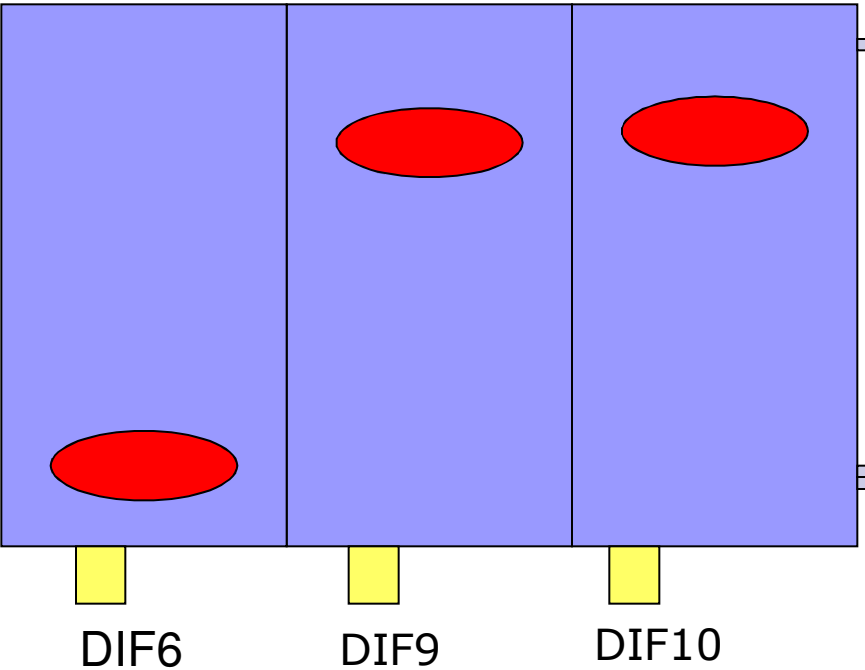
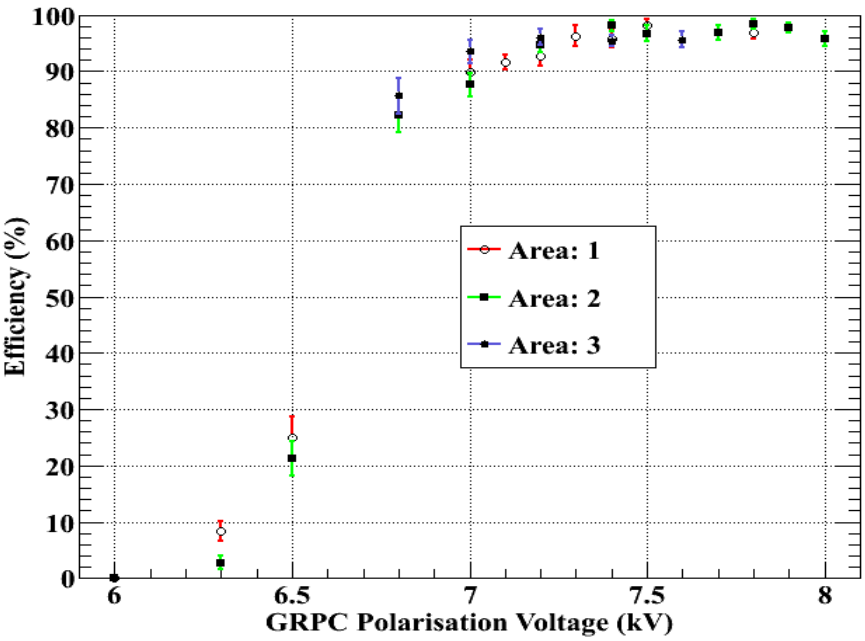
First structure

- PCB of 50X33.3 cm² 8-layer, class 6 (buried vias)
- 6 were equipped with hardroc1 (plastic packaging) → 144 ASICs
- PCB are connected 2 by 2 using **zero resistor**
- DIF **connected directly** to PCB
- PCB fixed to a mechanical structure to make a flat 1m² PCB





144 ASICs, 9216 channels

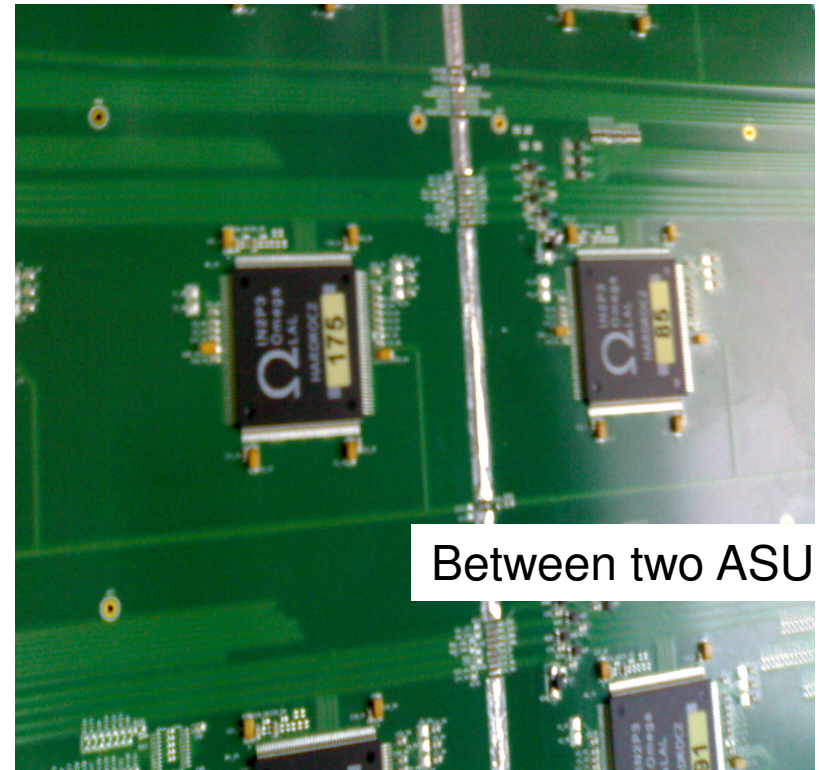
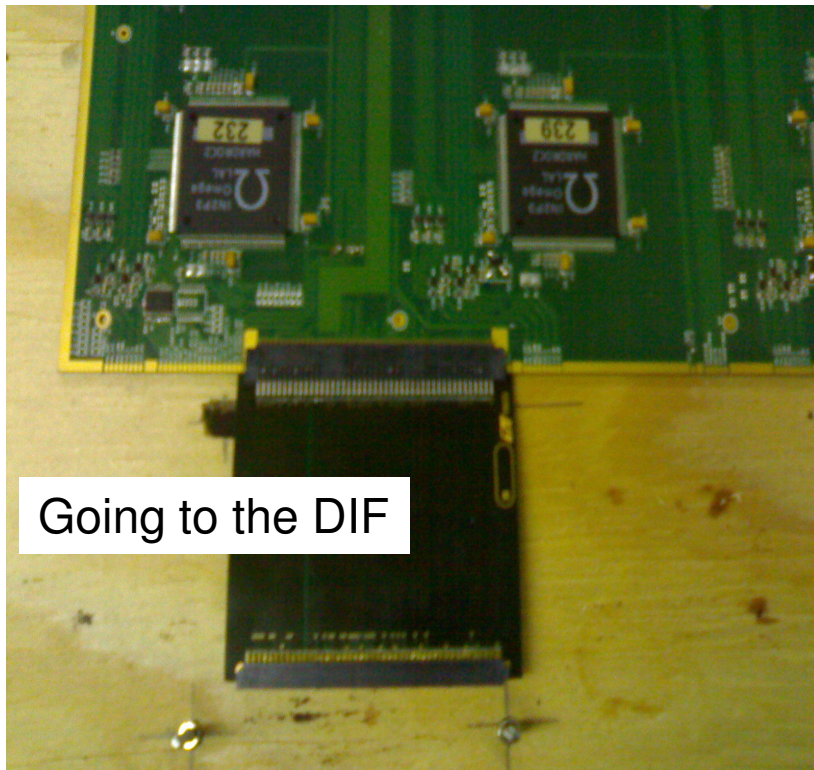


See Imad and Christophe talks

New structure

Learning from TB experience we improved our scheme :

Connections problems were fixed using flex (kapton)



New structure

15 PCB equipped with
HR2 and HR2b were produced



2 additional fully equipped
1m² GRPC are being assembled
using the new scheme

ASICs were tested using
Labview-based system

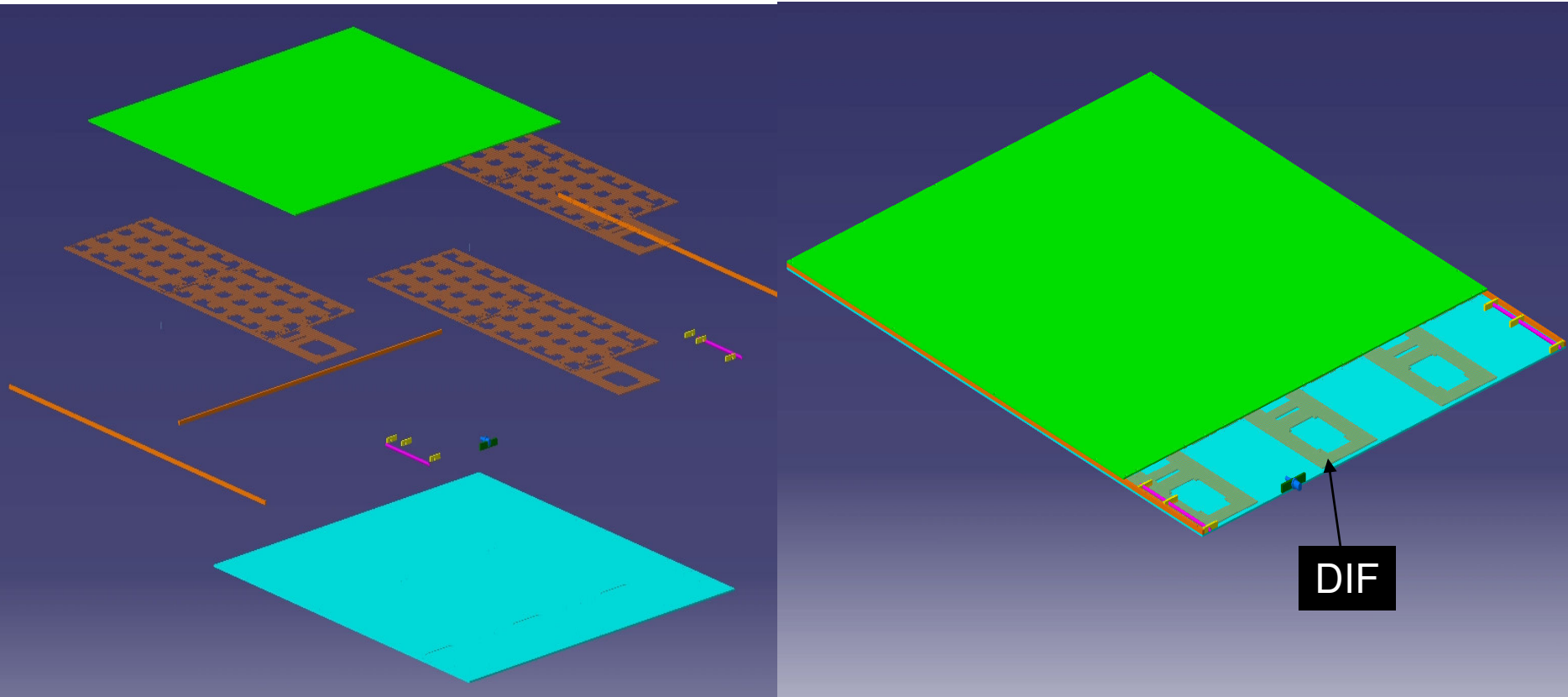
Slabs are tested after the ASICs
Are plugged using Xdaq-based
system.



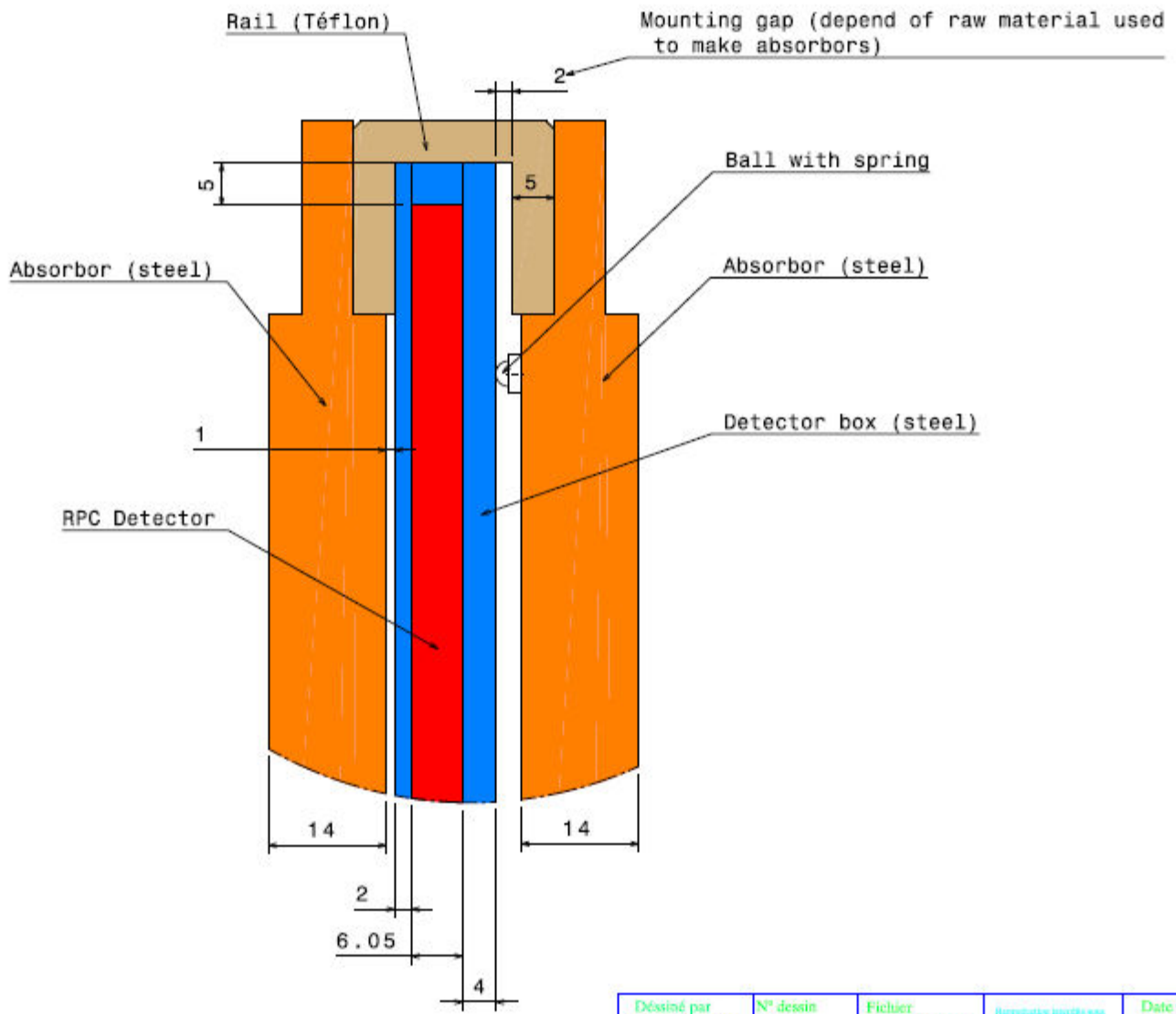
New structure

Cassette to include the GRPC detector and associated electronics was designed.

It allows to fix the electronics on one of the cassette wall using screws+ special glue.







Dessiné par BONNEVAUX	N° dessin numéro	Fichier 19 octobre 2009	Représentation illustrative sans valeur juridique	Date 16-10-2009	Echelle
			CALICE DHGAL		
PROTOTYPE M3			Edition 01	Feuille 01	



Services

→ High voltage service

→ Gas distribution system

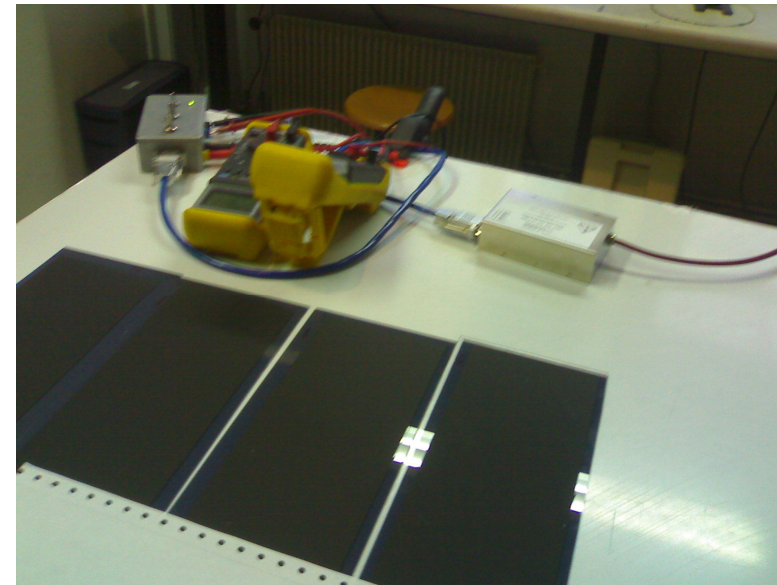
High Voltage

Cockcroft-Walton system is selected as the baseline for the technological prototype. It satisfies safety requirement and ILD volume limitation.

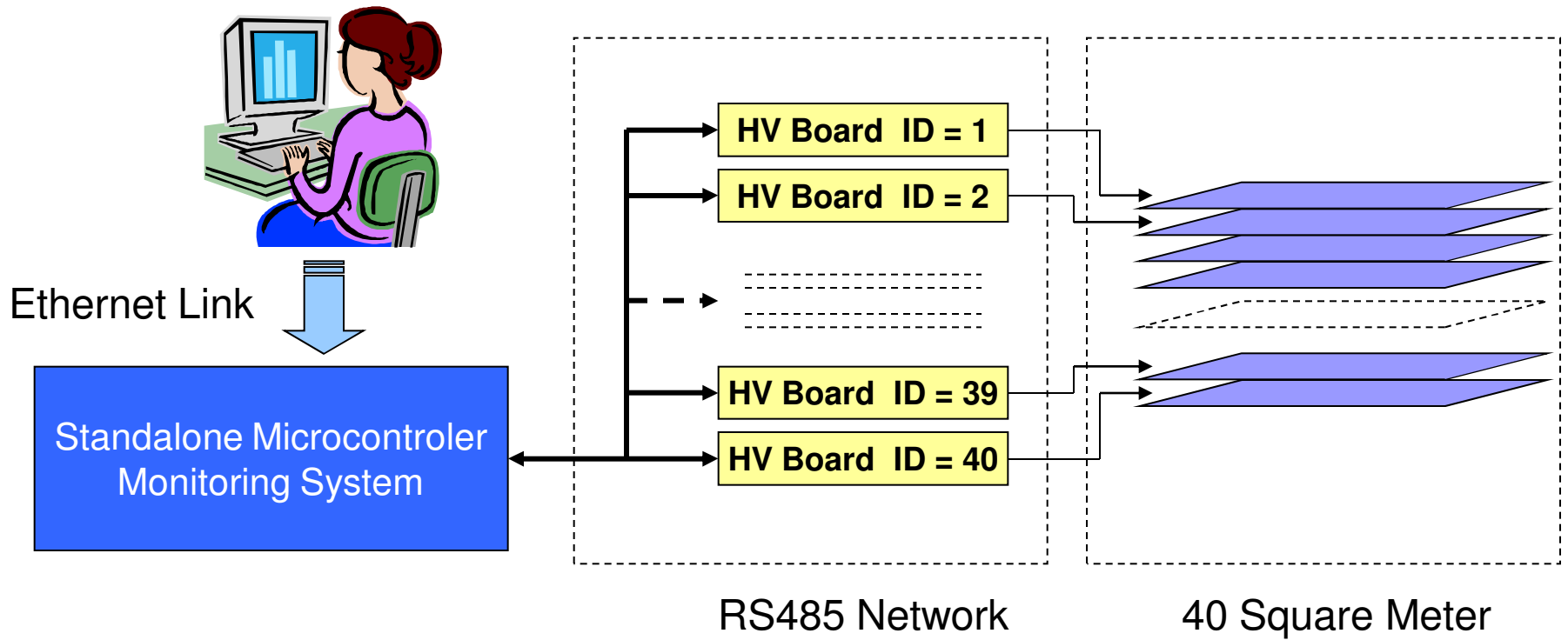
This was developed in collaboration with ISEG company.

Characteristics:

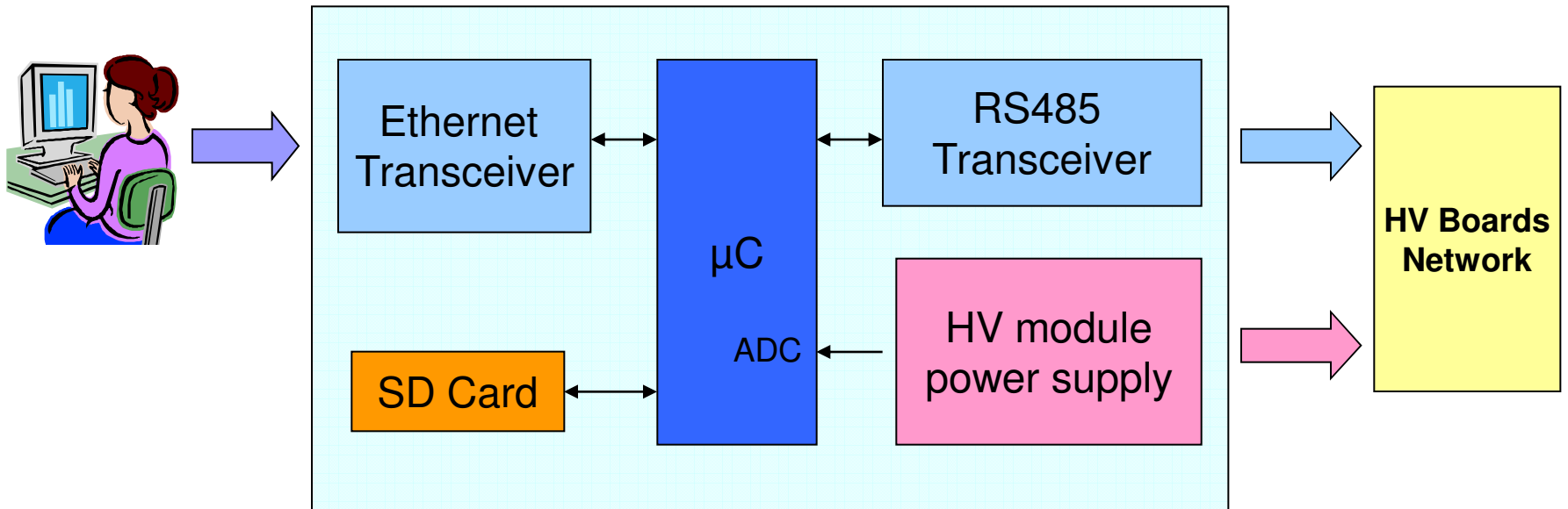
- 0-5 V \rightarrow 0-10 kV
- $I < 10\mu\text{A}$
- I, V monitoring
- Residual noise 50 mV



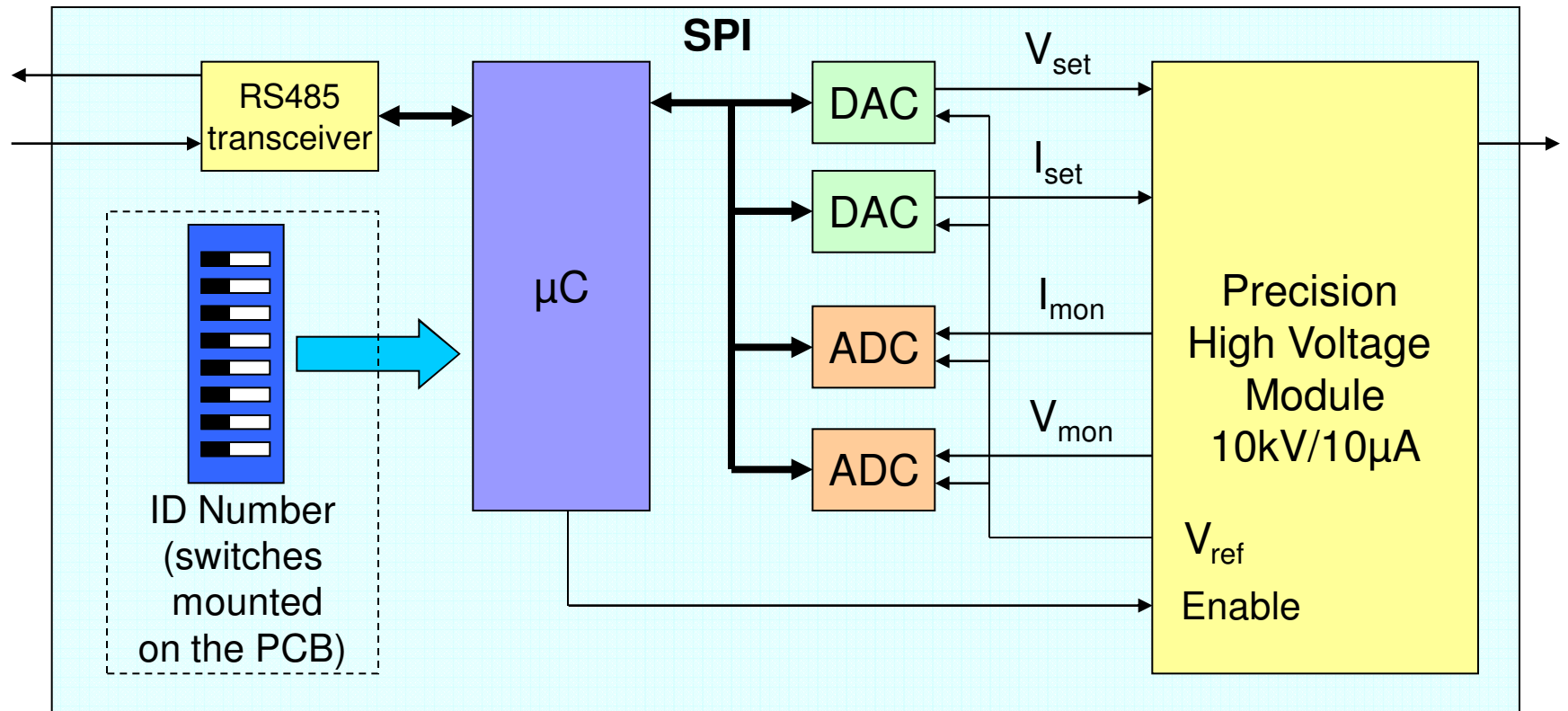
HV Network



Standalone Microcontroller Monitoring System



HV Board Overview Diagram



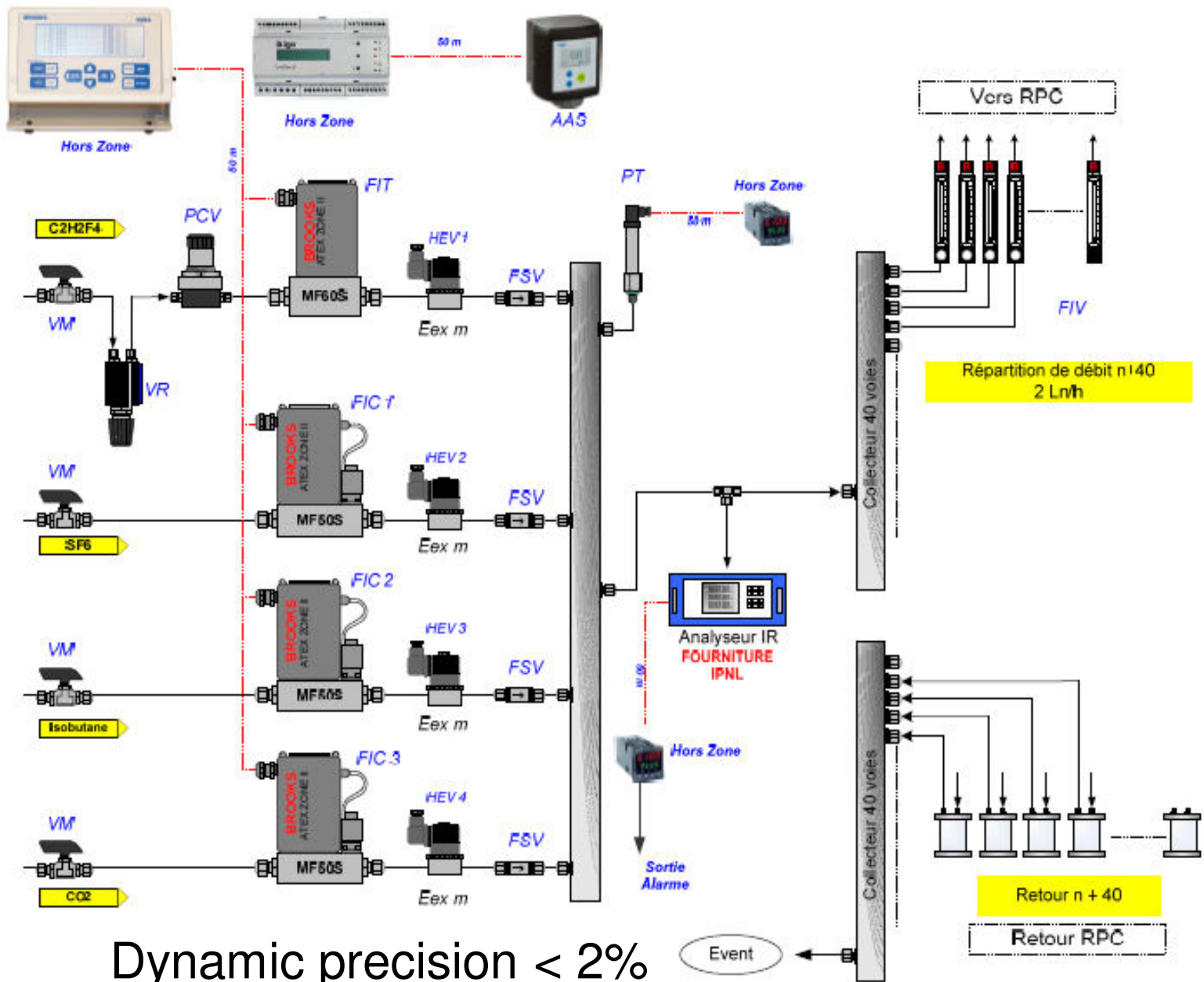


Gas distribution system

A system able to feed 40 detectors in parallel is being designed in collaboration with a French company

It is conceived to reduce contamination risk and to guarantee a good control of the gas mixture components

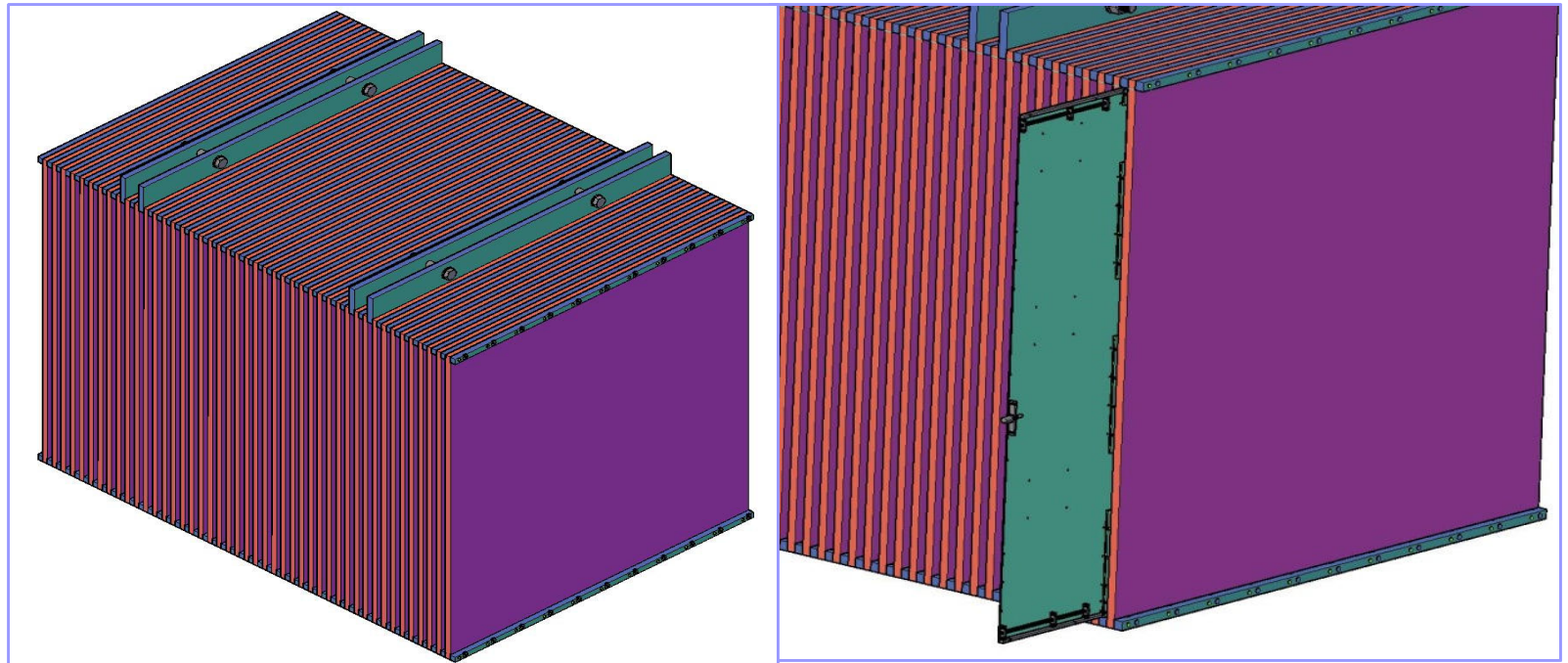
It satisfies CERN safety rules (very important)



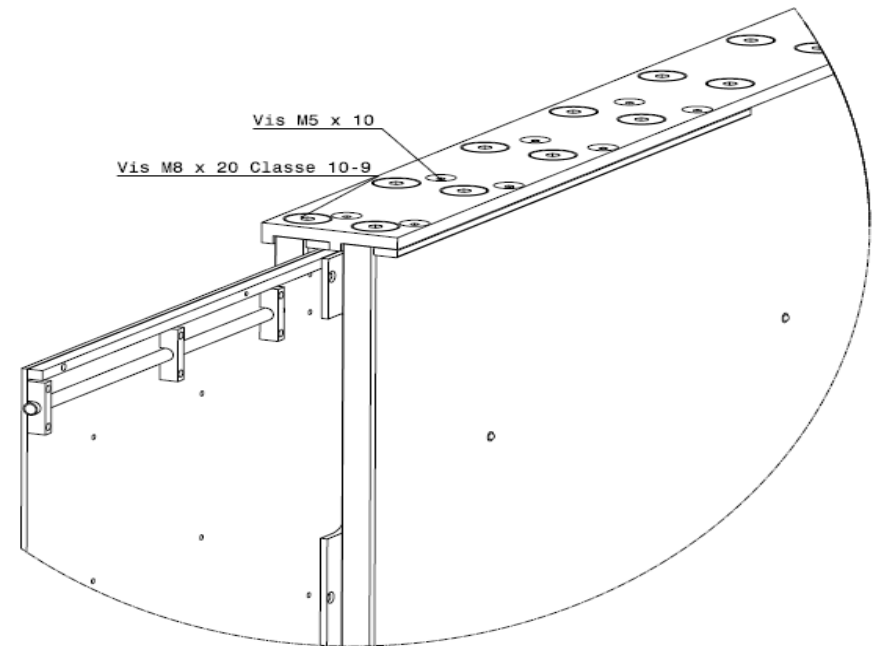
Dynamic precision <math>< 2\%</math>

Event

Mechanical structure



See Enrique talk



Fixation solutions

Thermal Study

■ Model

- 100 mW chips (no power pulsing)
- No cooling , thermal dissipation by convection only,

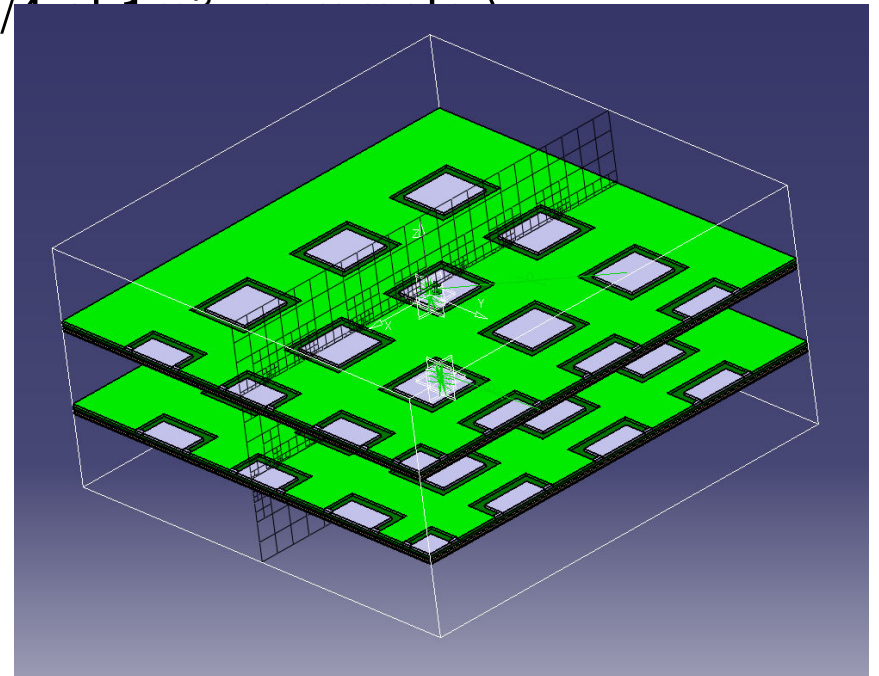
$$T(\text{hall}) = 20^\circ\text{C}$$

(still we should include the DIF effect in the future)

- 3 absorbers et 2 detecteurs (1/4, 1/2, 2/4, 1/2, 1/4)
- Cubic grid

■ Codes

- Catia V5
- EFD flomerics

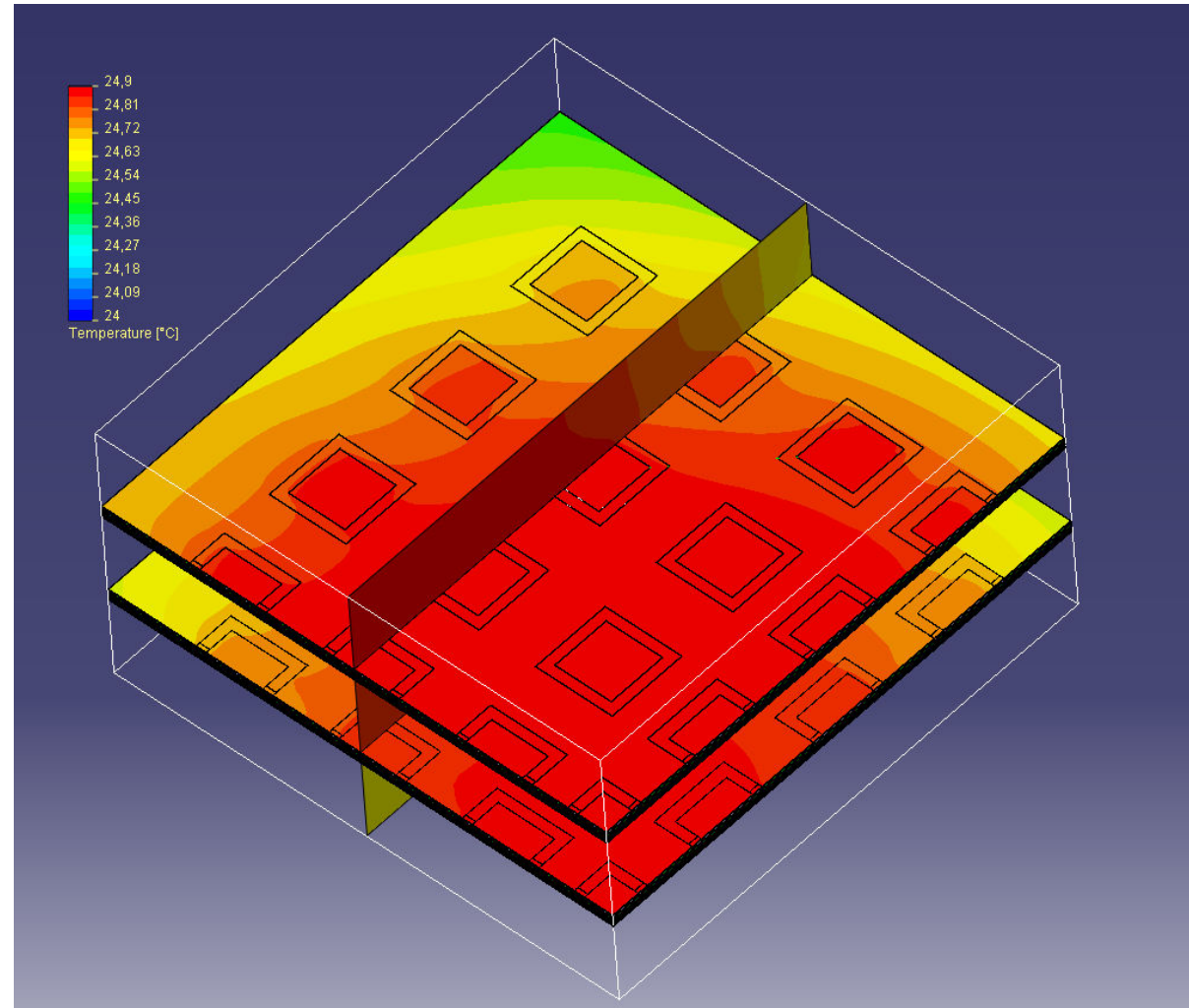


Thermal Study

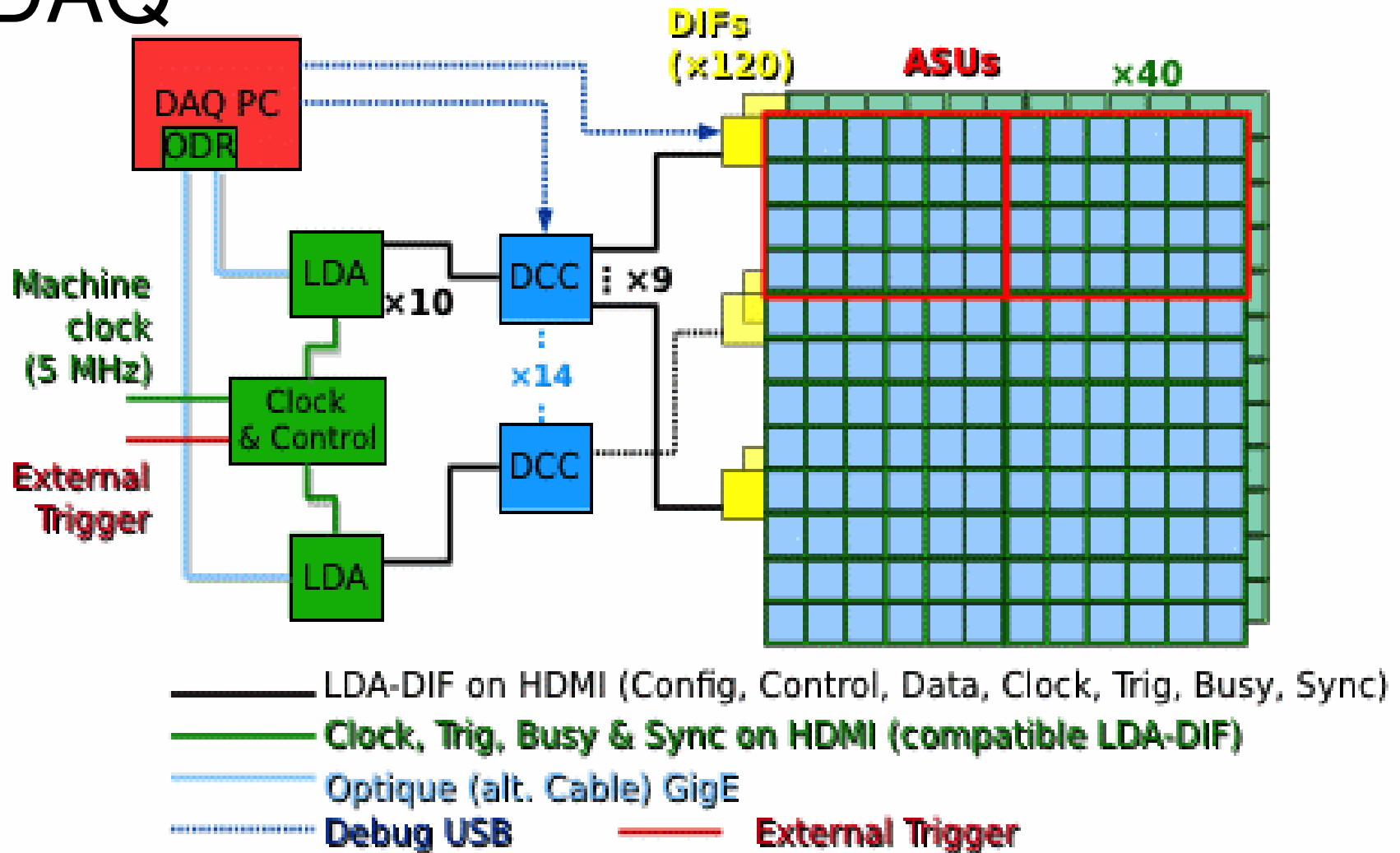
■ Resultats

$$T_{\max} = 25^{\circ}\text{C}$$

No cooling needed



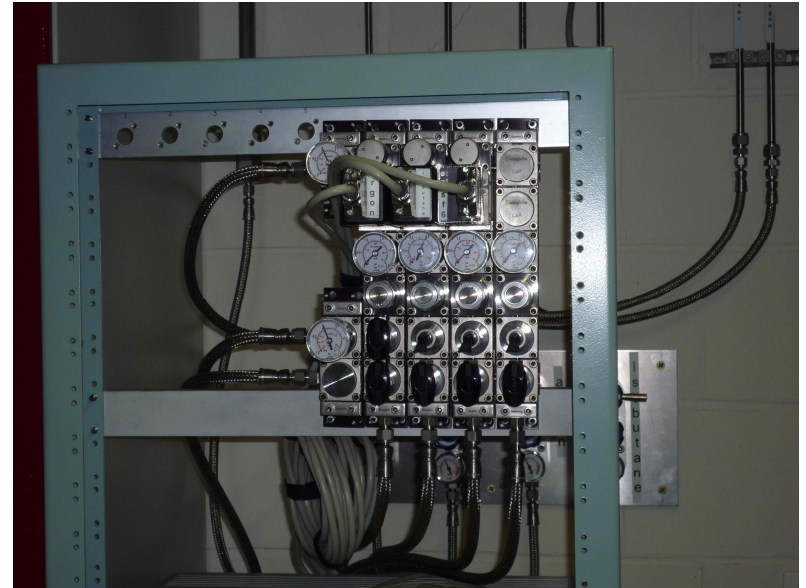
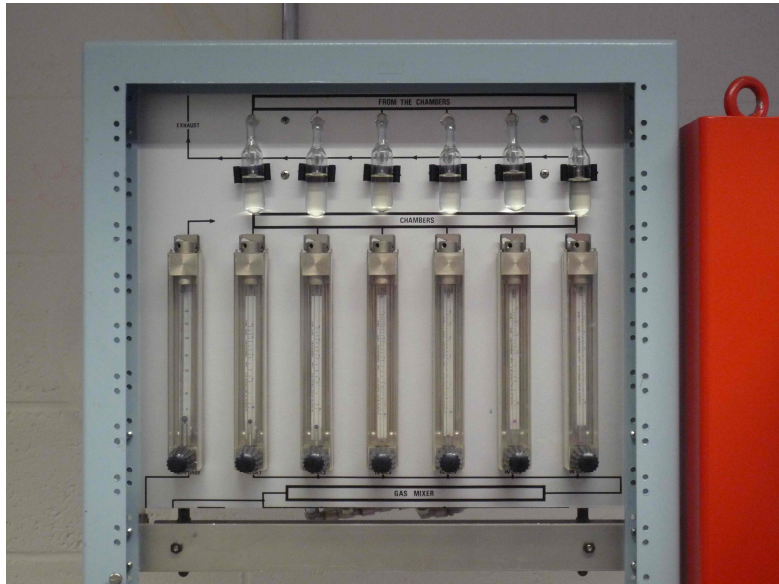
DAQ



See Vincent and Julie talks

Cosmic Test Bench in LLN

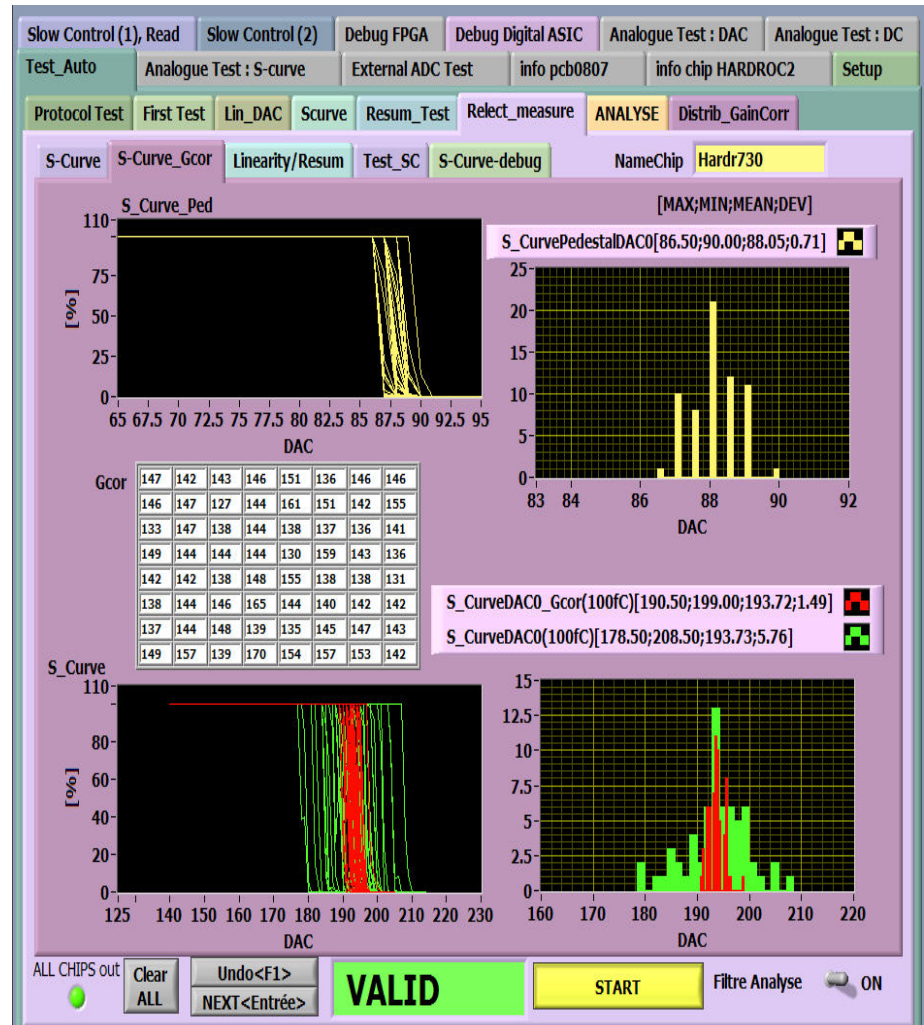
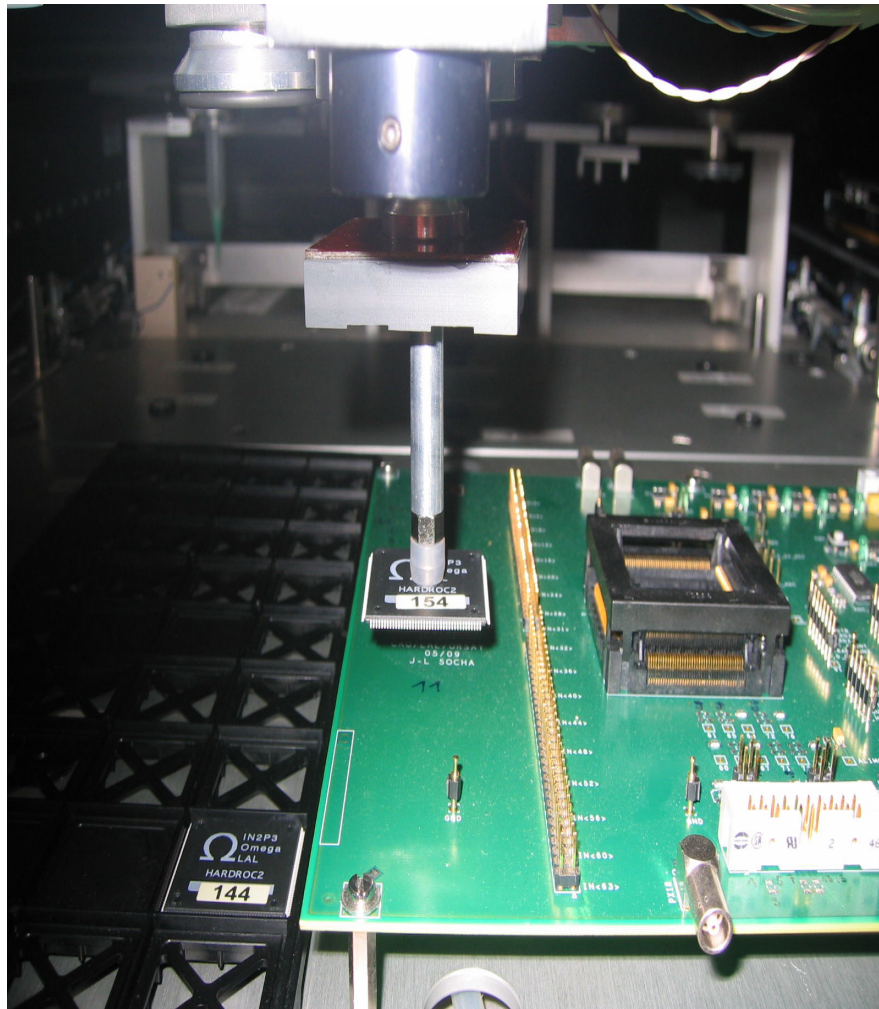
A teststand under preparation in Louvain-la-Neuve laboratory using (scintillators+fibers+PMT) Will be used to test the detectors



Chips test bench in Lyon

A CMS robot is being adapted to test the ASICs

Max test time : 10 minutes/ASIC using Labview-based application





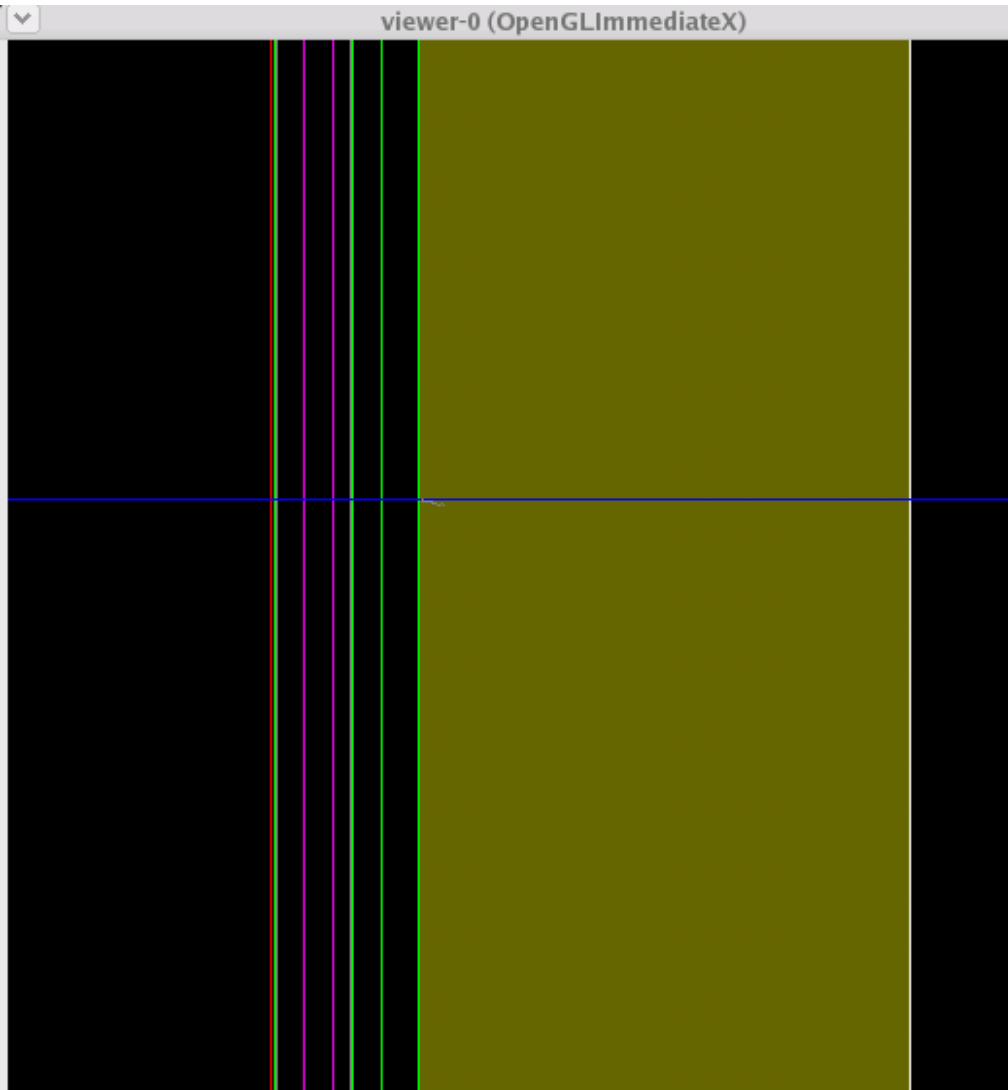
Simulation and performance study

Simulation should be as realistic as possible

This means :

- 1- Including dead zones and edge effects
- 2- Obtaining the same efficiency and multiplicity as for data

The structure of one layer

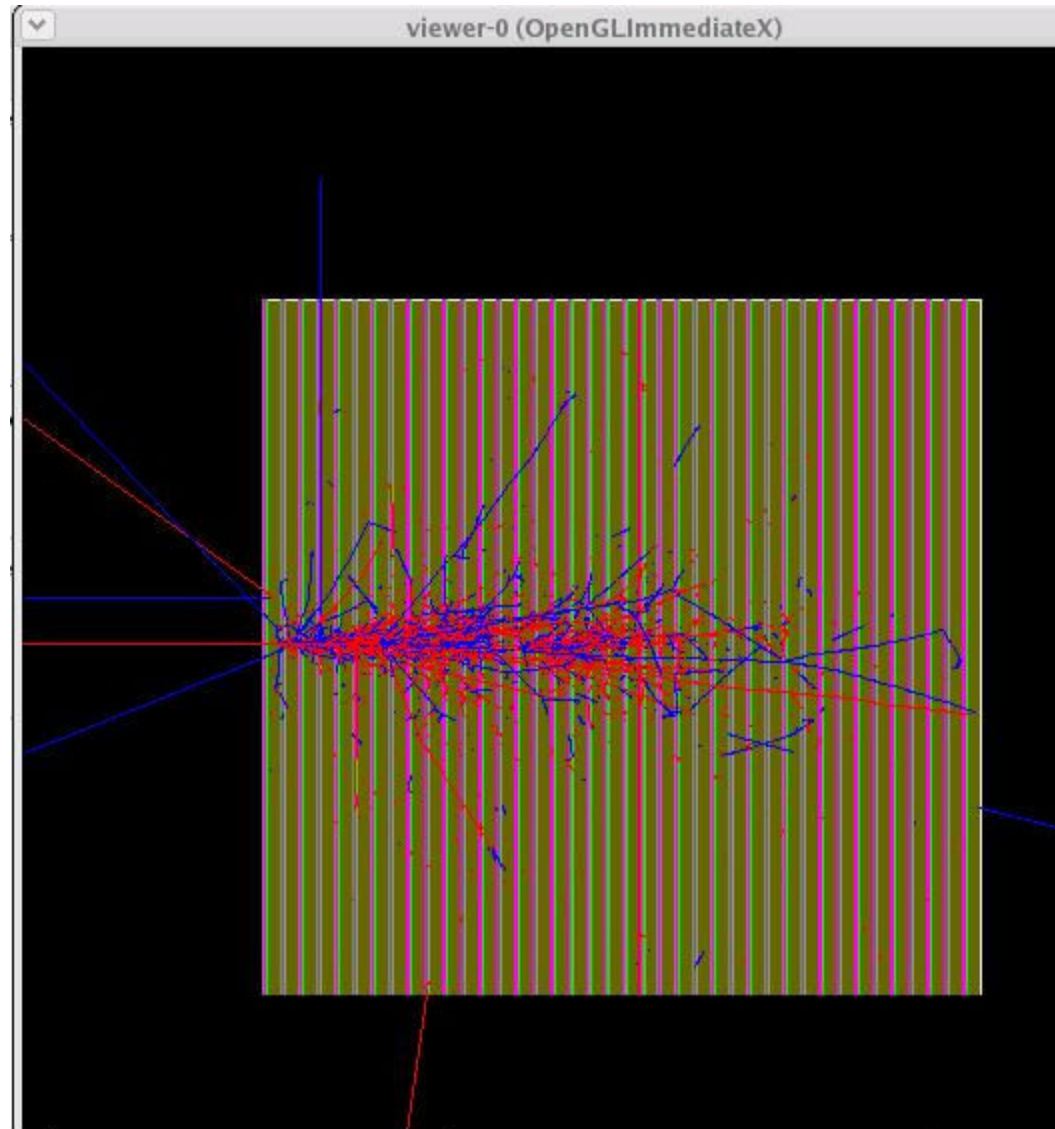


- PCB=1.20*mm;
- Mylar_Anode =0.05*mm; (Red)
- Mylar Cathode =0.18*mm;
- Graphite_Anode= 0.05*mm; (Green)
- Graphite Cathode=0.05*mm; (Green)
- Thin Glass=0.700*mm; (Gray)
- Gap =1.200*mm;
- Thick Glass =1.10*mm;
- ChipPackageThickness =1.50*mm;
- Absorber =2.00cm (Yellow)

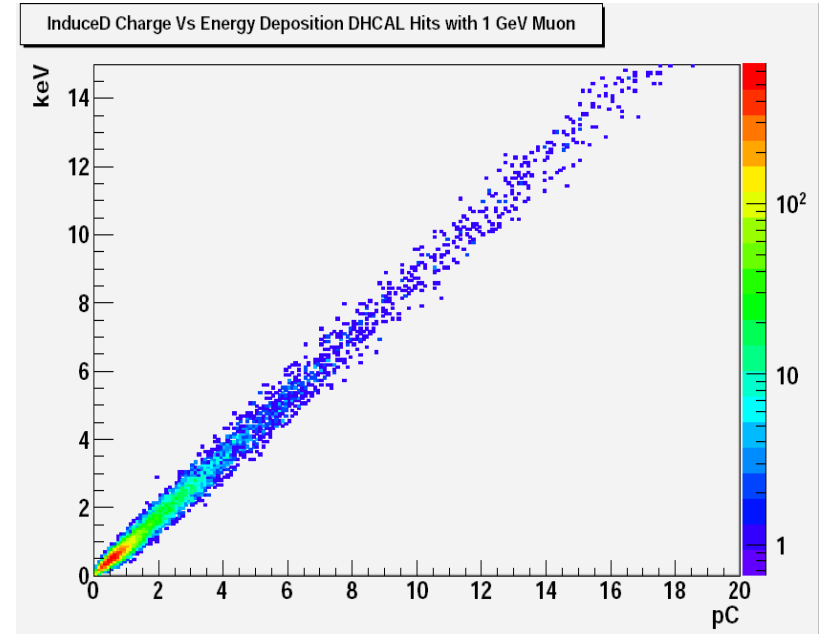
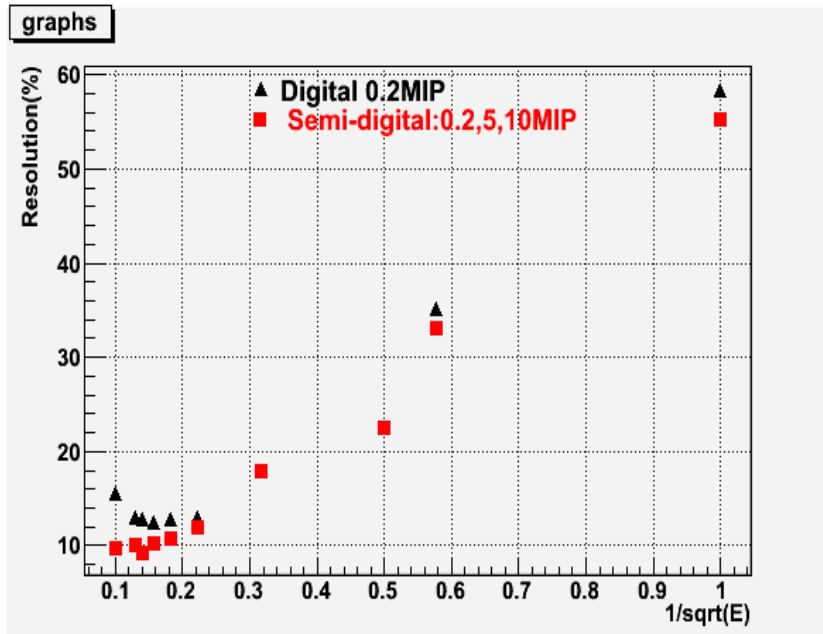
- TFE:SF6:ISO(V)=94.5: 0.5: 5
- TFE:SF6:ISO(M)=96.4: 0.7: 2.9

- Beam Direction: from $-Z$ to $+Z$, from electronics to absorber

40-layer prototype with 100 GeV pion event



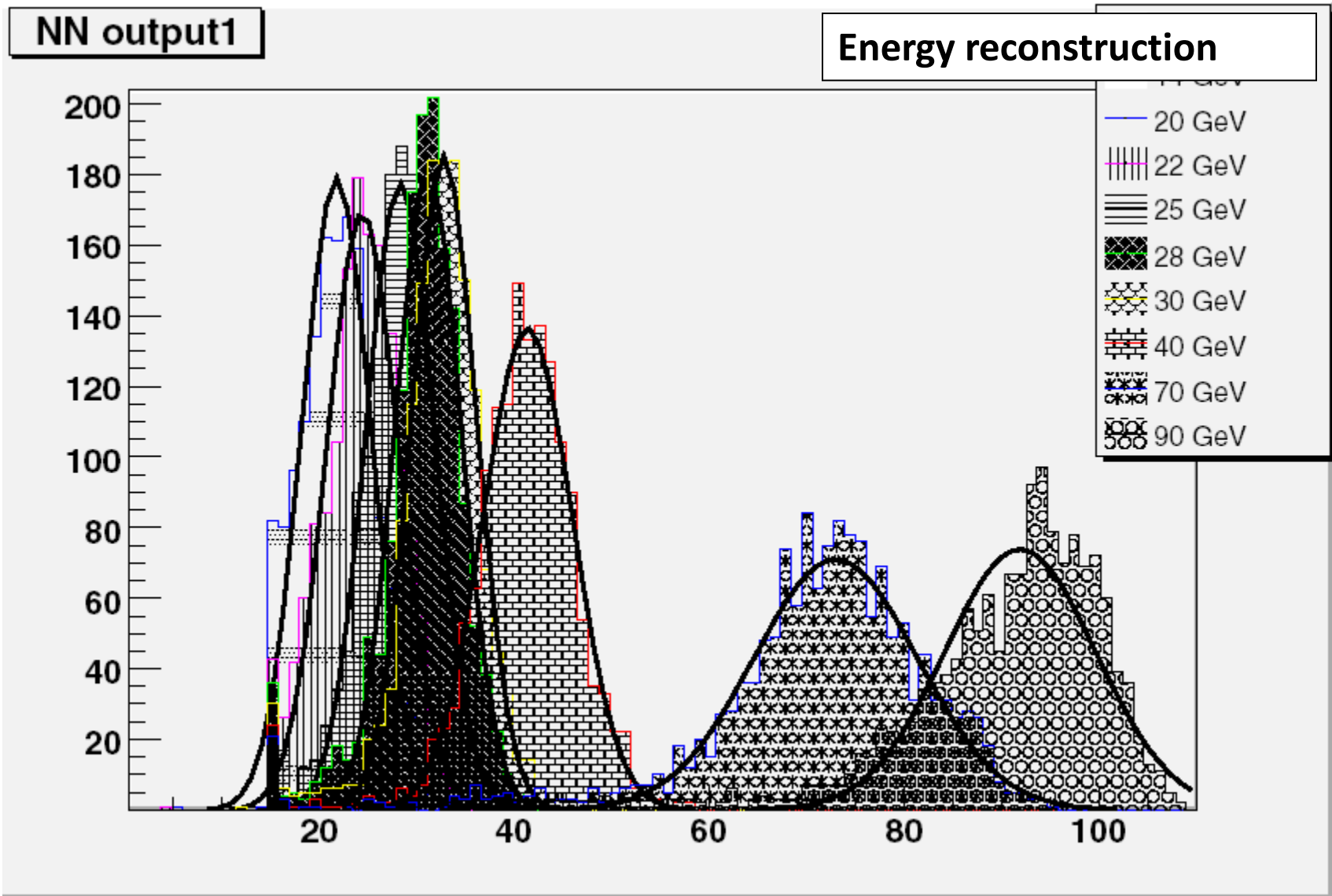
Selection of the threshold values and the weight of each threshold was made using a Chi2 optimization.
 “Weights are energy dependent”



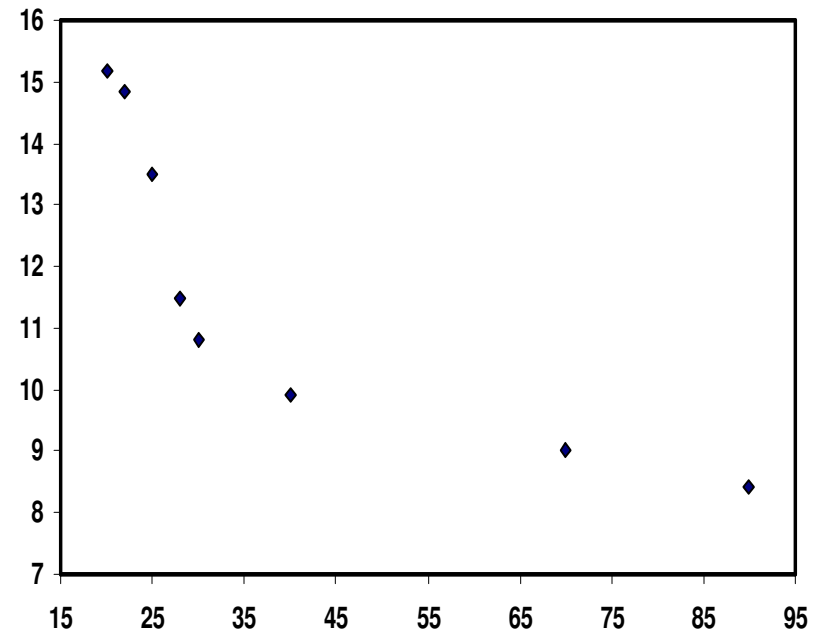
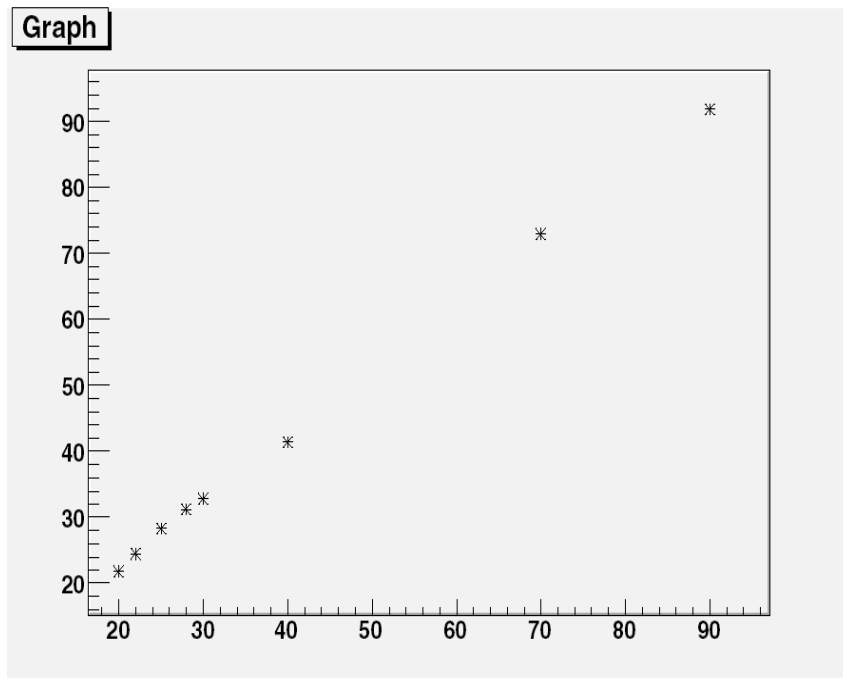
Based on accumulated dE/dX in each cell. We are reproducing the same study based on the accumulated charged

However, using a polya function to convert energy into charge
 There is a linearity

To determine the energy a NN can be very helpful



Linearity, resolution Vs Beam Energy: Semi-Digital (0.2,5,10MIP) using NN



Only semi-digital information taken into account. Work to include the shower shape and hits density is ongoing

Conclusion

- A lot of progress has been made in different fields in the technological SDHCAL prototype
- We are almost ready to start the mass production
- We think we can have our technological prototype ready for TB in 2011
- We intend to replace our standard RPCs by MGRPCs in a second step and probably with semi-conductive GRPCs.